Application/Control No. Applicant(s)/Patent Under Reexamination 10/522,772 FUNAHATA ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 2871 David Y. Chung **U.S. PATENT DOCUMENTS** Document Number Date Classification Name Country Code-Number-Kind Code MM-YYYY 349/43 US-7,053,969 05-2006 Yamazaki et al. Α US-В US-С US-D US-Ε US-F US-G US-Н US-

FOREIGN PATENT DOCUMENTS

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